

U.S. Department of Commerce, Patent and Trademark Office					Atty Docket No.		Serial No.	
					M-9131 US		Unknown	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT					Applicant			
(Use several sheets if necessary)					James M. Holden			
					Filing Date		Group	
					Herewith		Unknown	
U.S. Patent Documents								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	4,999,010	Mar. 12, 1991	Mattson et al.	356	346		
	AB	6,075,612	Jun. 13, 2000	Mandella et al.	356	445		
	AC	6,084,662	Jul. 4, 2000	Seaburn	356	73		
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
Foreign Patent Documents								
							Translation	
		Document	Date	Country	Class	Subclass	Yes	No
	AL	WO 00/12961	9 Mar 2000	PCT				
	AM							
	AN							
	AO							
	AP							
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AQ	Gamsky, C. et al., "Quantitative analysis of chemically amplified negative photoresist using mirror-backed infrared reflection absorption spectroscopy" <i>SPIE Vol. 2438</i> , Pages 143-152.						
	AR	Gamsky, C., "Reflectance FT-IR For Monitoring Chemical Reactions In Chemically Amplified Photoresists For 0.25 μ m X-Ray Lithography" UMI Dissertation Services, at the University of Wisconsin-Madison (1995), Pages 1-250.						
	AS							
Examiner				Date Considered				
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.								

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30 Oct 01
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